

Docket Number: 081468-0308582

SPW
PATENT APPLICATION

Client Reference: P-1820.000-US



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

KLAUS SIMON

Group Art Unit: 1762

Application No.: 10/792,267

Examiner: Unassigned

Filed: March 4, 2004

Confirmation No.: 4229

For: PRINTING APPARATUS AND DEVICE MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

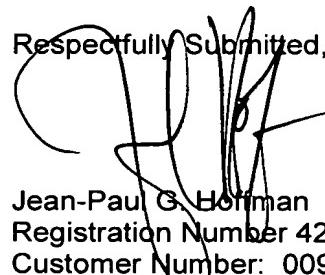
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. The non-U.S. patent references and the article are attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicant respectfully requests the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicant with the next Office communication to indicate that the references have been considered, per MPEP § 609.

This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

Respectfully Submitted,


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Date: October 24, 2005
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INFORMATION DISCLOSURE CITATION IN AN APPLICATION <small>Form PTO-1449</small>		Docket Number 081468-0308582	Application Number 10/792,267
		Applicant(s) Klaus SIMON	
		Filing Date March 4, 2004	Group Art Unit 1762

*OCT 24 2005
U.S. PATENT & TRADEMARK OFFICE*

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	6,921,615	B2 07/26/2005	Sreenivasan et al.	430	22	
	B	6,719,915	B2 04/13/2004	Willson et al.	216	44	
	C	6,696,220	B2 02/24/2004	Bailey et al.	430	272.1	
	D	6,656,341	B2 12/02/2003	Petersson et al.	205	667	
	E	6,518,189	B1 02/11/2003	Chou	438	706	
	F	6,482,742	B1 11/19/2002	Chou	438	690	
	G	6,375,870	B1 04/23/2002	Visovsky et al.	264	1.31	
	H	6,365,059	B1 04/02/2002	Pechenik	216	52	
	I	6,334,960	B1 01/01/2002	Willson et al.	216	52	
	J	6,309,580	B1 10/30/2001	Chou	264	338	
	K	6,165,911	12/26/2000	Calveley	438	754	
	L	5,772,905	06/30/1998	Chou	216	44	
	M	5,512,131	04/30/1996	Kumar et al.	156	655.1	
	N	2005/0064054 A1	03/24/2005	Kasumi	425	112	
	O	2005/0039618 A1	02/24/2005	Heidari et al.	101	368	
	P	2004/0219461 A1	11/04/2004	Chung et al.	430	311	
	Q	2004/0219249 A1	11/04/2004	Chung et al.	425	385	
	R	2004/0209470 A1	10/21/2004	Bajorek	438	689	
	S	2004/0200411 A1	10/14/2004	Willson et al.	118	500	
	T	2004/0192041 A1	09/30/2004	Jeong et al.	438	689	
	U	2004/0169003 A1	09/02/2004	Lee et al.	216	4	
	V	2004/0149367 A1	08/05/2004	Olsson et al.	156	64	
	W	2004/0124566 A1	07/01/2004	Sreenivasan et al.	264	494	

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REF	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translations	
						YES	NO
X	WO 01/79592 A1	10/25/2001	PCT				
Y	WO 01/79591 A1	10/25/2001	PCT				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

X	Stephen Y. Chou, et al., "Nanoimprint Lithography", J. Vac. Sci. Technol. B 14(6), November/December 1996, pgs. 4129-4133.
Y	

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.	

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		081468-0308582	10/792,267
		Applicant(s)	
		Klaus SIMON	
		Filing Date	Group Art Unit
		March 4, 2004	1762

Form PTO-1449

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*EXAMINER INITIAL	REF	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	2004/0081798 A1	04/29/2004	Lee et al.	428	141	
	B	2004/0046288 A1	03/11/2004	Chou	264	479	
	C	2004/0036201 A1	02/26/2004	Chou et al.	264	402	
	D	2004/0022888 A1	02/05/2004	Sreenivasan et al.	425	174.4	
	E	2004/0021866 A1	02/05/2004	Watts et al.	356	401	
	F	2004/0009673 A1	01/15/2004	Sreenivasan et al.	438	694	
	G	2004/0005444 A1	01/08/2004	Heidari	428	212	
	H	2003/0189273 A1	10/09/2003	Olsson	264	293	
	I	2003/0170053 A1	09/11/2003	Montelius et al.	399	318	
	J	2003/0159608 A1	08/28/2003	Heidari	101	494	
	K	2003/0141291 A1	07/31/2003	Heidari et al.	219	460.1	
	L	2003/0139042 A1	07/24/2003	Heidari	438	689	
	M	2003/0127580 A1	07/10/2003	Ling et al.	249	115	
	N	2003/0081193 A1	05/01/2003	White et al.	355	72	
	O	2003/0080472 A1	05/01/2003	Chou	264	338	
	P	2003/0080471 A1	05/01/2003	Chou	264	338	
	Q	2003/0034329 A1	02/20/2003	Chou	216	44	
	R	2002/0177319 A1	11/28/2002	Chou	438	690	
	S	2002/0167117 A1	11/14/2002	Chou	264	338	
	T	2002/0132482 A1	09/19/2002	Chou	438	692	
	U	2002/0094496 A1	07/18/2002	Choi et al.	430	322	
	V	2002/0093122 A1	07/18/2002	Choi et al.	264	401	
	W						

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translations	
							YES	NO
	X							
	Y							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

X	
Y	
Z	
AA	

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